

Notice of References Cited	Application/Control No. 10/584,776	Applicant(s)/Patent Under Reexamination YAMAMOTO ET AL.	
	Examiner ADAM A. ARCIERO	Art Unit 1795	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0287439 A1	12-2005	Shimamura et al.	429/231.4
	B	US-			
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	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 03/079469	09-2003	Japan	Shimamura et al.	
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NON-PATENT DOCUMENTS

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	U	IPDL PAJ JPO machine translation JP 2000-173612. Nakamoto et al. (06-2000).
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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